



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 3, 2025	
IGI Report Number	LG739504704
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	6.95 X 6.86 X 5.00 MM

GRADING RESULTS

Carat Weight	2.07 CARATS
Color Grade	D
Clarity Grade	VVS 2

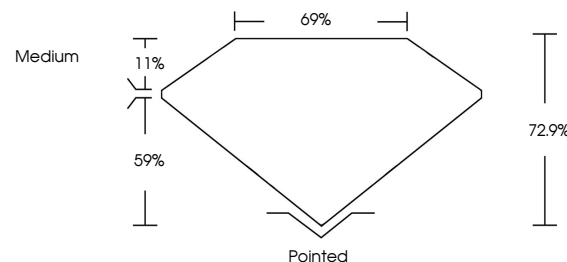
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG739504704

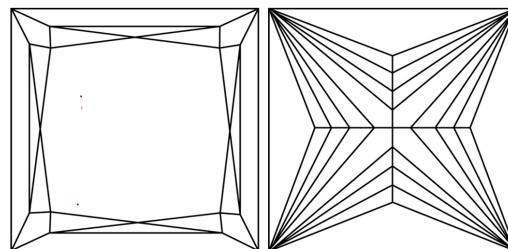
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG739504704
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

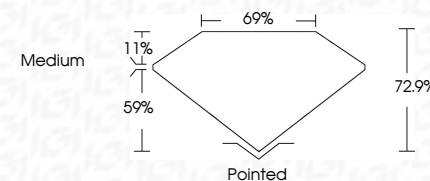
CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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GRADING RESULTS	
Carat Weight	2.07 CARATS
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Clarity Grade	VVS 2



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG73950470A
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



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October 3, 2025
 IGI Report No LG739504704
 PRINCESS CITT

Carat Weight	2.07 CARATS
Color Grade	D
Clarity Grade	VVS 2
Depth	72.9%
Table	69%
Grade	Medium
Culet	Pointed
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.